



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Robert D. Tolles et al.

Art Unit: 3724

Serial No.: 09/507,172

Examiner: Timothy V. Eley

Filed

: February 18, 2000

Title

: CHEMICAL MECHANICAL POLISHING SYSTEM HAVING MULTIPLE

POLISHING STATIONS AND PROVIDING RELATIVE LINEAR POLISHING

MOTION

Commissioner for Patents

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INFORMATION DISCLOSURE STATEMENT

Applicant submits the references listed on the attached form PTO-1449. Please apply any other charges or credits to Deposit Account No. 06-1050.

Respectfully submitted,

Date:___ 8/3/04

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| Substitute Form PTO-1449 | U.S. Department of Commerce | Attorney's Docket No. | Application No. | |
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| • (Modified) | Patent and Trademark Office | 05542-170006 | 09/507,172 | |
| Information Disclo by Appl (Use several sheet | | Applicant Robert D. Tolles et al. | | |
| (Use several sheets if necessary) | | Filing Date February 18, 2000 | Group Art Unit 3724 | |

| U.S. Patent Documents | | | | | | | |
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| 775×AMME | Desig. ID | Document Number | Publication Date | Patentee | Class | Subclass | Filing Date If Appropriate |
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| Other Documents (include Author, Title, Date, and Place of Publication) | | | | |
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